Journal of Materials Chemistry C



CORRECTION

View Article Online
View Journal | View Issue



Cite this: *J. Mater. Chem. C*, 2015, **3**, 8434

Correction: High density and patternable growth of silicon, germanium and alloyed SiGe nanowires by a rapid anneal protocol

M. Bezuidenhout, ^{ab} T. Kennedy, ^b S. Belochapkine, ^b Y. Guo, ^b E. Mullane, ^b P. A. Kiely and K. M. Ryan*

DOI: 10.1039/c5tc90134k

www.rsc.org/MaterialsC

Correction for 'High density and patternable growth of silicon, germanium and alloyed SiGe nanowires by a rapid anneal protocol' by M. Bezuidenhout *et al.*, *J. Mater. Chem. C*, 2015, **3**, 7455–7462.

Ref. 49 of the manuscript has been updated as follows;

49 T. Kennedy, M. Bezuidenhout, K. Palaniappan, K. Stokes, M. Brandon and K. M. Ryan, ACS Nano, 2015, DOI: 10.1021/acsnano.5b02528.

The Royal Society of Chemistry apologises for these errors and any consequent inconvenience to authors and readers.

a Department of Life Sciences, and Materials and Surface Science Institute, University of Limerick, Limerick, Ireland

b Materials and Surface Science Institute and Department of Chemical and Environmental Sciences, University of Limerick, Limerick, Ireland. E-mail: Kevin.m.ryan@ul.ie